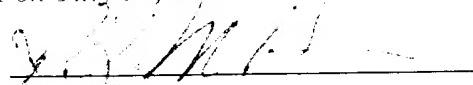


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 01 2000



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R.L. Milton

Applicant : Francis M. Reininger
Application No. : 09/547,790
Filed : April 12, 2000
Title : SPATIALLY MODULATED INTERFEROMETER AND BEAM SHEARING DEVICE THEREFOR

Grp./Div. : 2877
Examiner : n/a

Docket No. : 39260/RAG/C766

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Post Office Box 7068
Pasadena, CA 91109-7068
July 26, 2000

Commissioner:

Entry of the following amendments prior to examination of the referenced application is respectfully requested:

IN THE SPECIFICATION:

At page 17, line 6, delete the colon (":") and insert a period (---); and,

At page 17, delete lines 7-12.

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